



Attorney Docket No.: SAM-0526  
Application Serial No.: 10/796,507  
Reply to Office Action of: June 13, 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Ki Hwan Park, *et al* Examiner: El Arini, Zeinab  
Serial No.: 10/796,507 Group Art Unit: 1746  
Filing Date: March 9, 2004  
Title: METHOD OF RINSING AND DRYING SEMICONDUCTOR  
SUBSTRATES (As Amended)

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10/11/06  
Date

Christina Harris  
Christina Harris

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Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT C**

Sir:

The following is in response to the Office Action dated June 13, 2006. A petition for a one-month extension of the time period in which to respond is filed concurrently herewith.

Please amend the application as follows.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.